OIPE IAP45 SEP 22 2005 PATENT & TRADEMARK OFFICE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:	)	
Kenshi KANEGAE et al.	)	Group Art Unit: 1765
Serial No. 10/679,464	)	Examiner: Kin Chan Chen
Filed: 10/7/2003	)	Confirmation No. 5297
For: ETCHING METHOD, SEMICONDUCTOR AND FABRICATING METHOD FOR THE SAME	)	Date: September 22, 2005

CERTIFICATE OF MAILING OR TRANSMISSION
[37 CFR 1.8(a)]

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Name: _____

REQUEST FOR RECONSIDERATION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated June 22, 2005, it is respectfully requested that the rejections set forth therein be reconsidered and withdrawn by the Examiner for the following reasons.